

FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. <b>03500.011080.9</b>		APPLICATION NO. <b>NYA</b>	
				APPLICANT <b>YOSHIKAZU BANNO ET AL.</b>			
				FILING DATE <b>FILED HEREWITH</b>			GROUP <b>1734</b>
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
BT		3,611,077	10/71	Smith	315	94	
		5,023,110	6/91	Nomura et al.	427	49	
		5,650,199	7/97	Chang et al.	427	333	
		5,320,703	6/94	Ikeda	117	68	
		4,566,186	1/86	Bauer et al.	29	852	
		4,668,533	5/87	Miller	427	98	
		4,891,242	1/90	Ito et al.	427	53.1	
		5,114,744	5/92	Cloutier et al.	427	96	
		5,275,646	1/94	Marshall et al.	106	20B	
		5,401,535	3/95	Bishop	427	229	
		5,832,595	11/98	Maruyama et al.	29	829	
		5,861,227	1/99	Ikeda et al.	430	31	
		5,505,777	4/96	Clardella	118	663	
		5,498,444	3/96	Hayes	427	162	
		4,600,137	7/86	Comerford	228	102	
	5,593,499	1/97	Stans	118	63		
	6,169,356	1/01	Ohnishi et al.	313	495		
	5,569,974	10/96	Morikawa et al.	313	310		
BT		5,066,883	11/91	Yoshioka et al.	313	309	
EXAMINER <u>B. T. Butler</u>				DATE CONSIDERED <u>12/7/04</u>			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
BT		5,627,111	5/97	Tsukamoto et al.	438	20	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
BT		0620581A	10/94	EPO			
		0658916A2	6/95	EPO			
		JP0256822	2/90	Japan			
		2-247939	10/90	Japan			
		64-5095	1/89	Japan			
		62-181490	8/87	Japan			
		63-200041	8/88	Japan			
		64-64290	3/89	Japan			
		1-296532	11/89	Japan			
		4-121702	4/92	Japan			
		JP 63-200041	8/88	Japan			
		2,013,233	9/90	Canada			English
		EP 0 394 698	10/90	EPO			
BT		JP 3-55738	3/91	JAPAN			Abstract
EXAMINER				DATE CONSIDERED			
BT, Tailor				12/7/04			

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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
BT		6,511,545	1/03	Banno et al.	118	688	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
BT		JP 63-200041	8/88	Japan			
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
BT		Patent Abstracts of Japan, Vol. 014, No. 573 (E-1015), December 19, 1990 & JP 02 247939 A (CANON INC.) October 3, 1990					
		H. Araki et al., "Electroforming and Electron Emission of Carbon Thin Films", J. Vac. Soc. Jpn., 26, 1, 22-29 (1981)					
		M. Hartwell et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", Int'l Electron Devices Mtg., Washington, D.C., 519-21 (1975)					
		G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, 9, 317-28 (1972)					
		W. Dyke et al., "Field Emission", Advances in Electronics and Electron Phys., 89-185 (1956)					
		M. Elinson et al., "The Emission of Hot Electrons and the Field Emission of Electrons from Tin Oxide", Radio Eng'g and Electronic Phys., 1290-96 (1965).					
		C. Mead, "Operation of Tunnel-Emission Devices", J. App. Phys., 32(4), 646-52 (1961).					
BT		C. Splndt et al., "Physical Properties of Thin-Film Field Emission Cathodes with Molybd num Cone," J. App. Phys., 47(12), 5240-63 (1976).					
EXAMINER				DATE CONSIDERED			
BT Talbot				12/7/04			

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